# PATENT APPLICATION

In re the Application of

Attn: OIPE

UNITED STATES PATENT AND TRADEMARK OFFICE

Shoji MIYAKE et al.

Application No.: 10/539,254 Docket No.:

123612

Filed: June 16, 2005

PLASMA GENERATOR, PLASMA CONTROL METHOD AND METHOD OF

PRODUCING SUBSTRATE

# REQUEST FOR CORRECTION OF PALM RECORDS

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Registration No. 27,075

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JAO:PAC/cqc

Date: November 22, 2005

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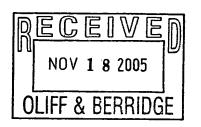


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/539,254	06/16/2005	1763	1750	123612	15	37	2

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**CONFIRMATION NO. 2416** 

Date Mailed: 11/16/2005

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### Applicant(s)

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## **Assignment For Published Patent Application**

Japan Science and Technology Agency, Kawaguchi-shi, JAPAN Shoji Miyake, Suita-shi, JAPAN Akinori Ebe, Kyoto-shi, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

# Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/16007 12/12/2003

#### Foreign Applications

JAPAN 2002-363988 12/16/2002 JAPAN 2002-363989 12/16/2002 JAPAN 2003-14718 01/23/2003

Projected Publication Date: 02/23/2006

Non-Publication Request: No

Next page ->

Early Publication Request: No

**Title** 

Plasma generation device; plasma control method, and substrate manufacturing method.
Plasma Gancrator, Plasma Control Mothod and Mcthod of Preliminary Class Producing Substrate

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